

DS - 10/23/2003 APPLICANT'S ART CITATION (Use several sheets if necessary)	Application	OFGS File No. P/16-346
	Applicant Takashi INOUE	
	Filing Date	Group Art Unit

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner /Gevell Selby/ Date Considered

02/05/2007

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.